Amendment and Response t Paper mailed 9/4/03

Sir:

Thank you for your continued expedient examination of the present Application.

In response to the Office Action mailed 9/4/03, please amend the above application as

follows:

Statement of Claims Status

Claims 18-33 are pending in the application.

Claims 18-33 are rejected.

Summary of Response

Detailed Action

Examiner States:

"The corrected or substitute drawings were received on Oct. 25, 2002. These drawings

are not acceptable. The association of the added box in Fig. 3 with box element 13 is

unclear."

Examiner States:

"Claims 18-33 are rejected under 35 U.S.C. 112, second paragraph, as being indefinite

for failing to particularly point out and distinctly claim the subject matter which applicant

regards as the invention.

It is unclear what is meant by "capital goods" in line 2 of claim 18.

Examiner States:

Amendment and Response to Final Office Action mailed 9/4/03

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Filing date: 10/6/2000

Art Unit: 2856

Date mailed: 11/9/2003 Attorney Docket No. ENP-01

Serial No: 09/680,286

Title: REMOTE MONITORING OF CRITICAL PARAMETERS FOR CALIBRATION OF

MANUFACTING EQUIPMENT AND FACILITIES

"In line 3 it is unclear what is meant by "critical parameters related to chemical / material

analysis techniques". I.e. how do they differ from measurements not related to such

techniques?"

Examiner States:

"Claims 18-33 are rejected under 35 U.S.C. 103(a) as being unpatentable over Moslehi

US 5,270,222 in view of (Renken et al US 5,967,661 or Melcher US 5,015,951).

Moslehi does not disclose attaching sensors, recording device and energy source

to a surface of the capital good (semiconductor wafer) being monitored. However it is

well known to incorporate such features into semiconductors and thus they obviously

could have been in the system of Moslehi especially in view of the teaching of

incorporation of sensors or sensing structure on material in either Renken et al (note

especially Fig. 9) and Melcher. It is noted that temperature as monitored by Renken can

be considered a critical parameter. Use of such element placement in Moslehi would

have obviously eased measuring by avoid signal transmission delays, etc. The various

electronic components and memory systems. etc. appear to be all well known of general

utility and could thus obviously have been incorporated thereinto."

Examiner States:

"Isolation from external hostile environments is a known expedient to protect the

equipment and get more accurate measurements."

Examiner States:

"One of ordinary skill would have been able to monitor in liquid environments since techniques for monitoring such environments appear to be well known."